

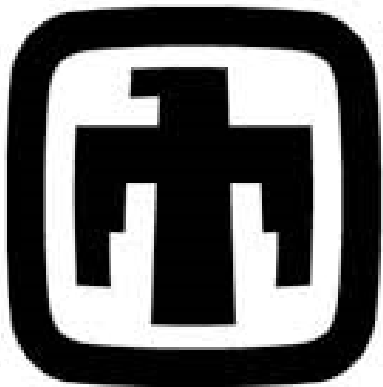
Photon-based Characterization of Single Ion Geiger Mode Avalanche Detectors: Experiments and Simulations

SAND2016-1875C

Peter A. Sharma

pasharm@sandia.gov

J. B. S. Abraham, J. Pacheco, M. Singh, E. Bielejec
T. Pluym, J. Dominguez, M. S. Carroll



**Sandia
National
Laboratories**

This work was performed, in part, at the Center for Integrated Nanotechnologies, an Office of Science User Facility operated for the U.S. Department of Energy Office of Science. Sandia National Laboratories is a multi-program laboratory managed and operated by Sandia Corporation, a wholly owned subsidiary of Lockheed Martin Corporation, for the U.S. Department of Energy's National Nuclear Security Administration under contract DE-AC04-94AL85000

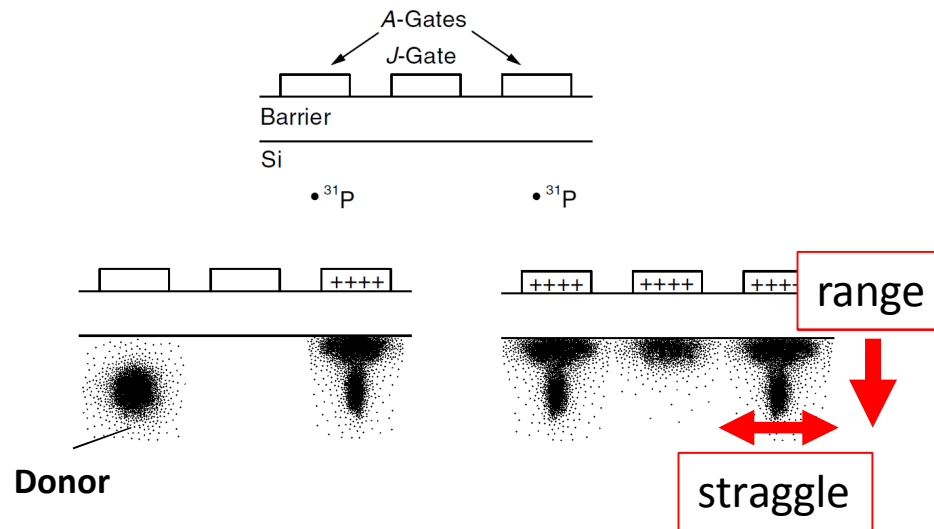
SAND:



U.S. DEPARTMENT OF
ENERGY



Quantum computer as an array of donors



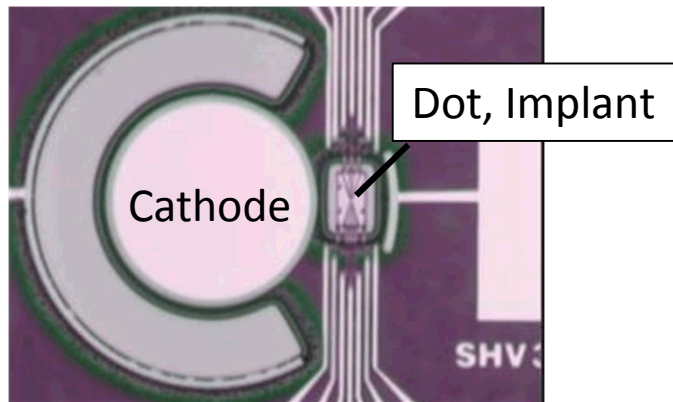
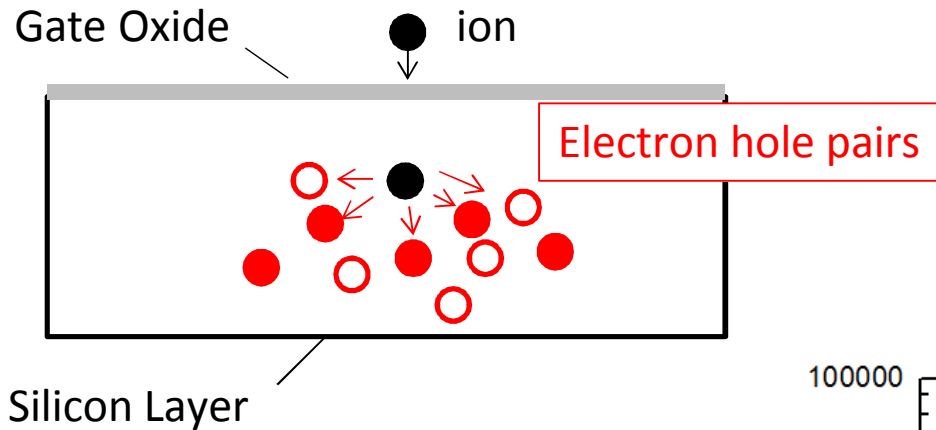
Kane. Fortschr. Phys. 00

Range/Straggle must be small
Lower energy: smaller range, straggle

Fabrication of arrays of single donors can be achieved through ion implantation

Challenge: detect very low energy ion implants at shallow depths with minimal straggle

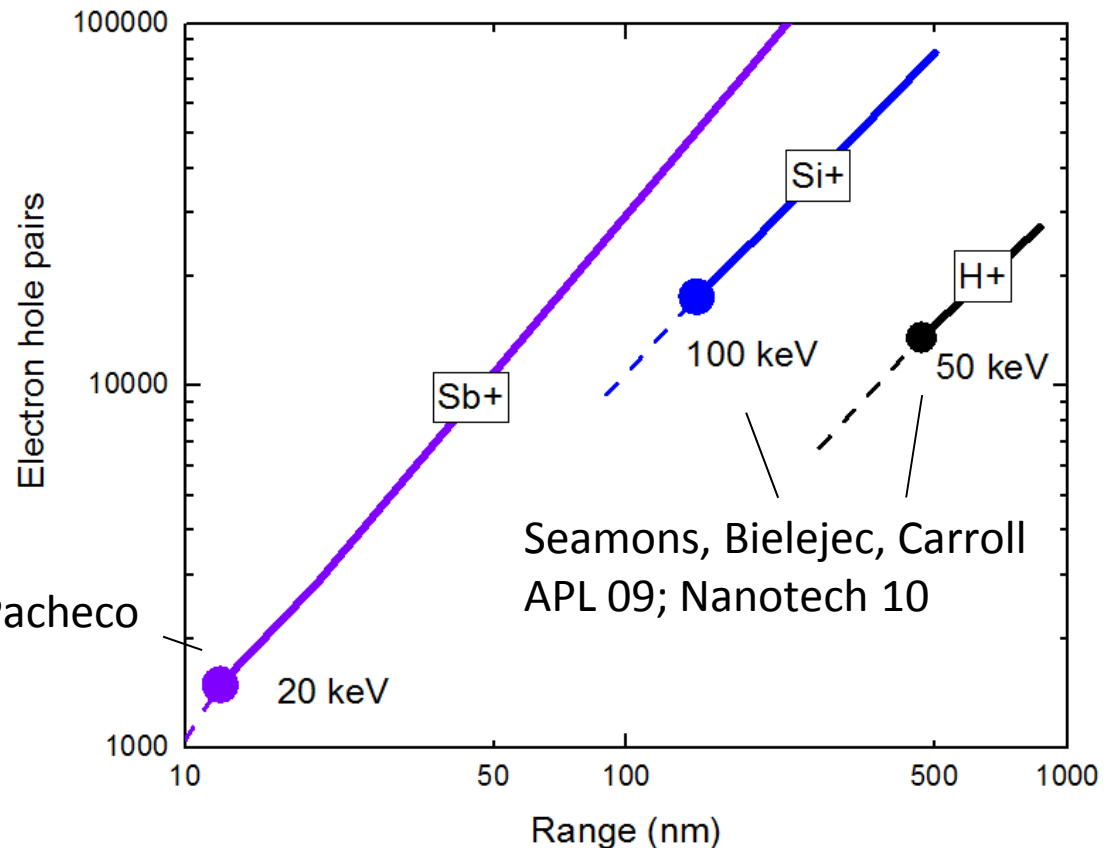
Shallow, low-straggle implants require detection of very small number of electron hole pairs



Detector + Dot

Singh, Pacheco

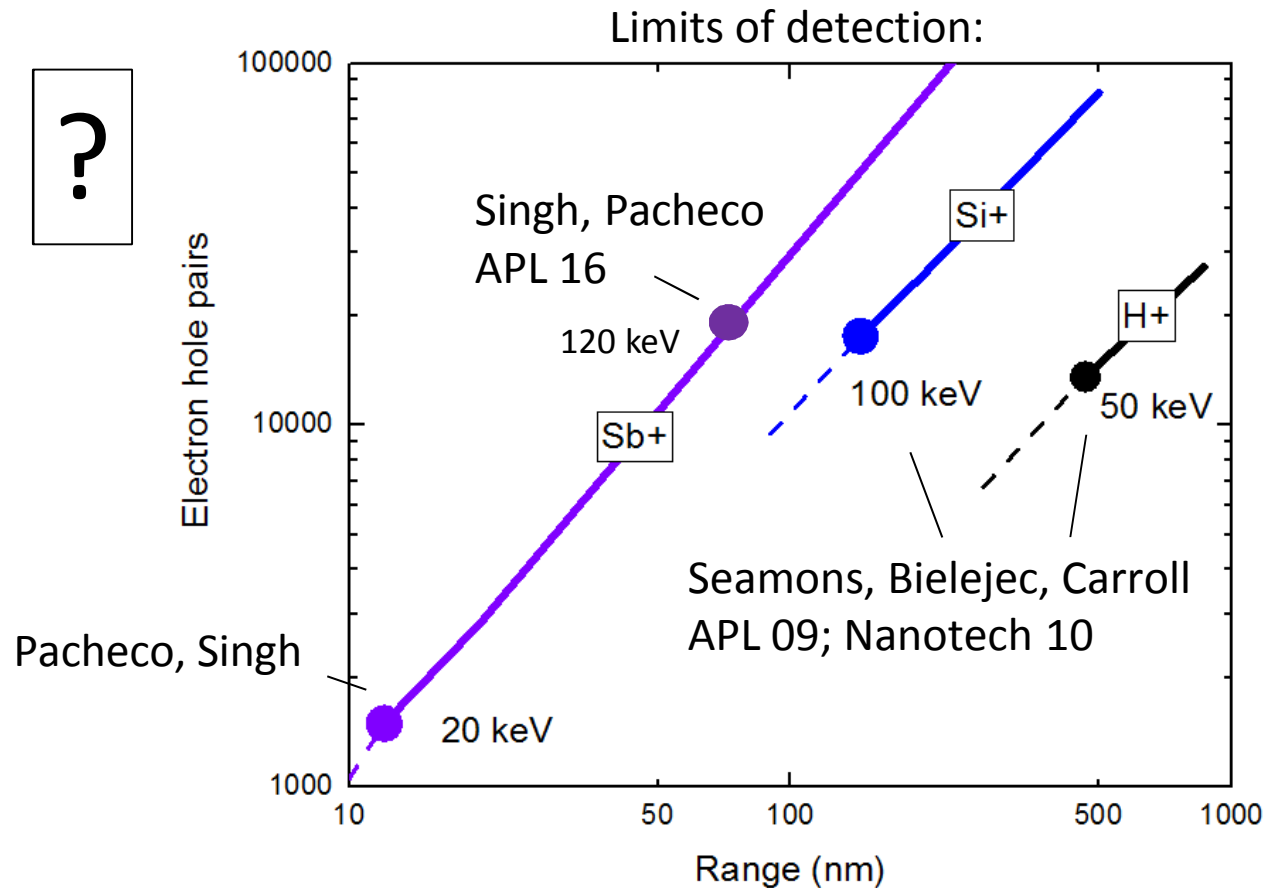
Detection in the few-ion limit



How do we improve detection?

Different species have different EH pair limits at different ranges

What are the limiting factors?



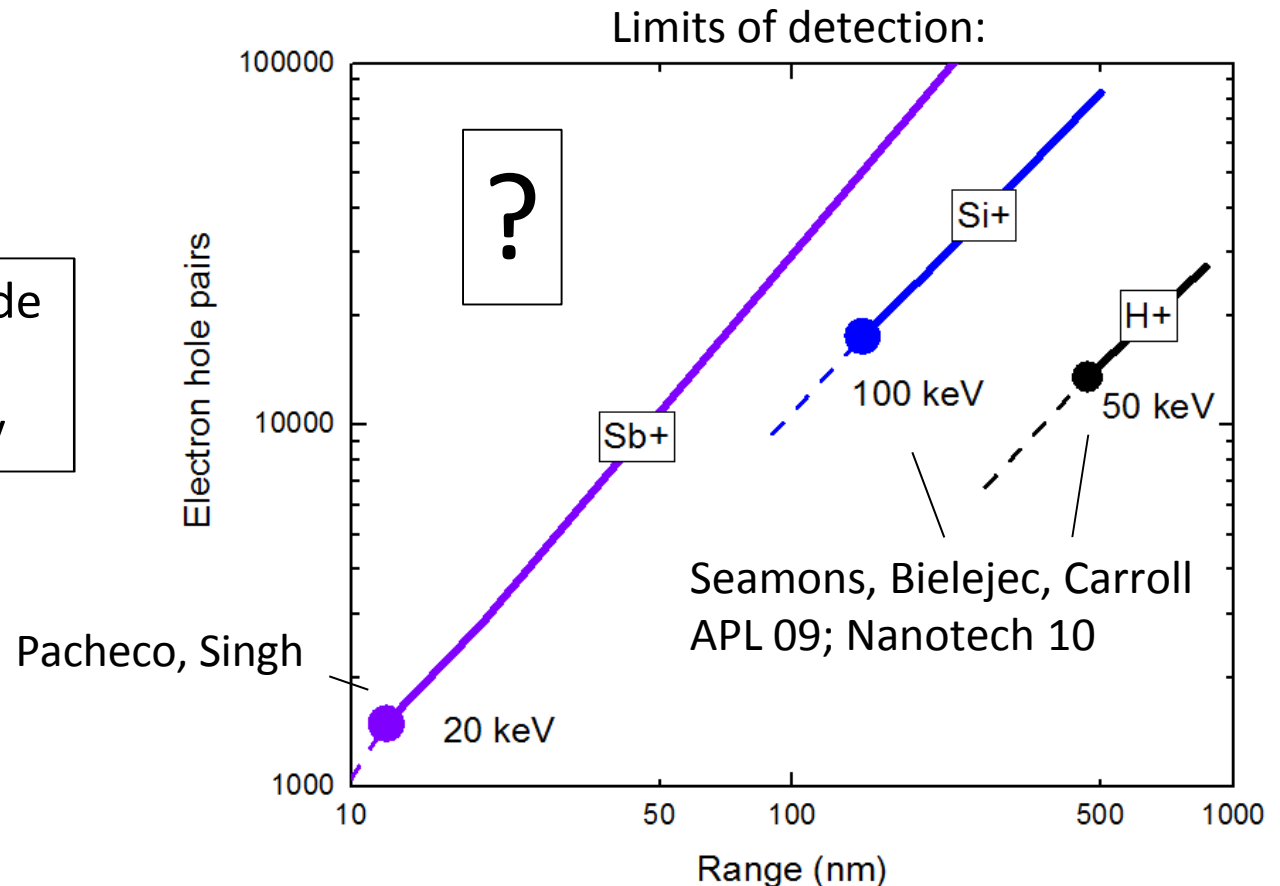
This work:

Understand Limiting factors for detection using Photons

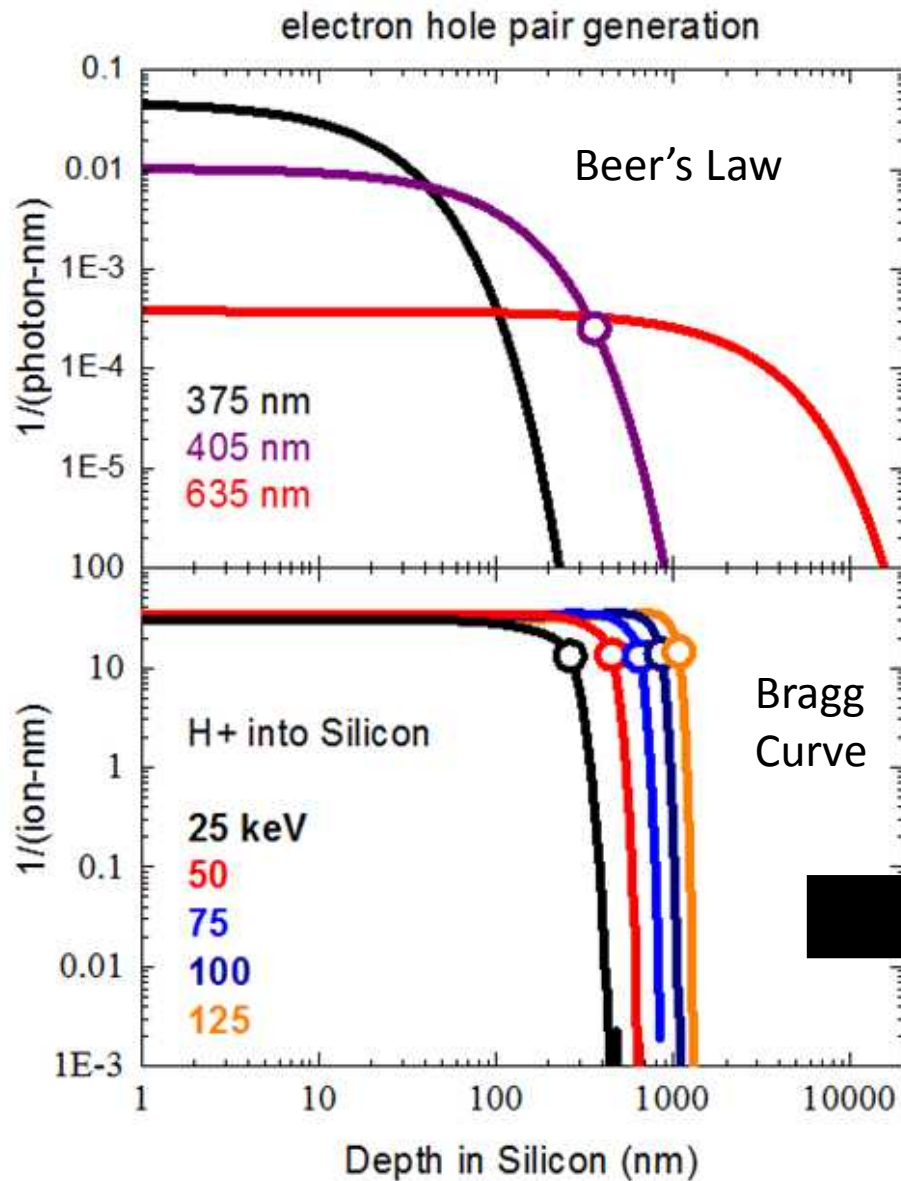
1. Develop photon characterization methods

2. Physics-based simulation for detection

We focus on Geiger-mode
detectors:
Single EH pair sensitivity



Photons are a damage-free proxy for Ions

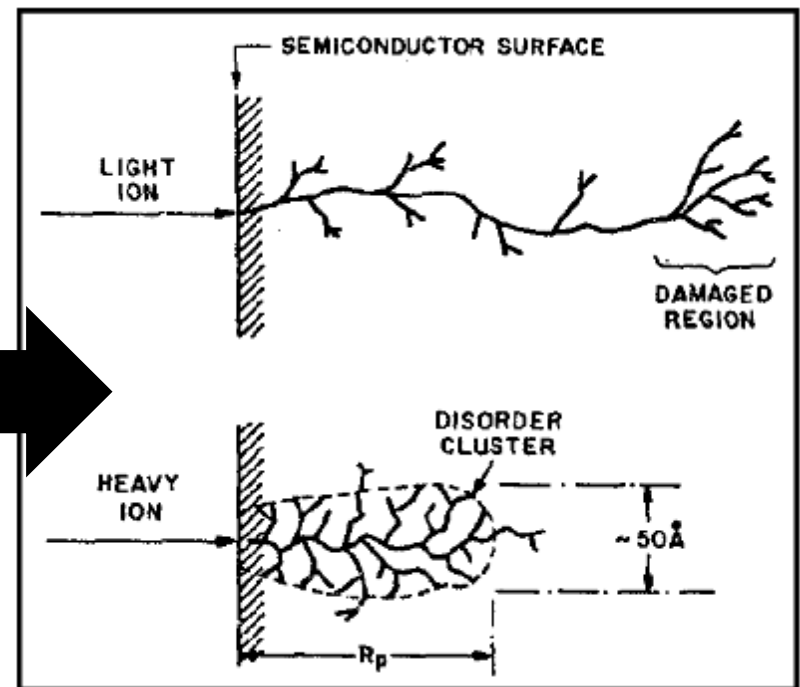


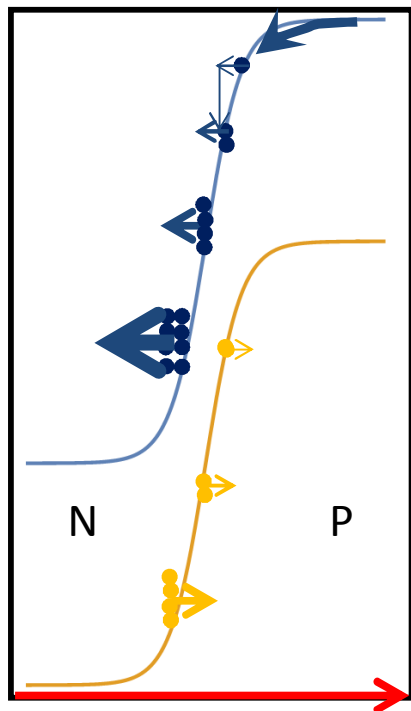
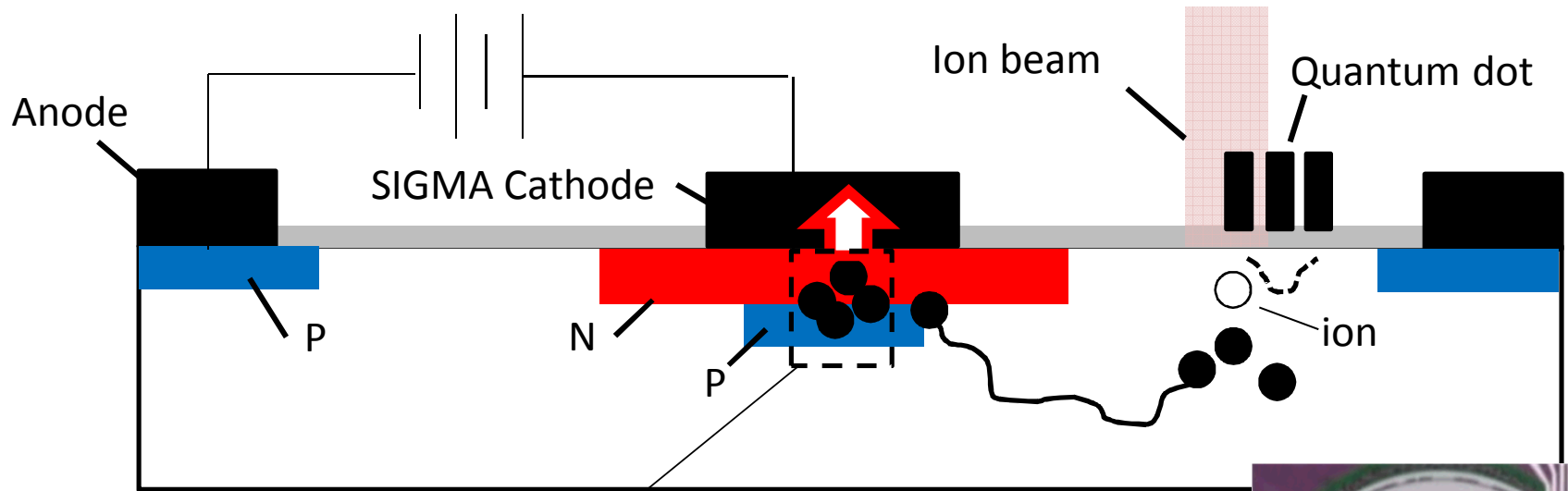
$$GR(z) = F(1 - R)\alpha e^{-\alpha z}$$

Photon flux

reflection

Absorption coefficient





Physics of SIGMA detectors:

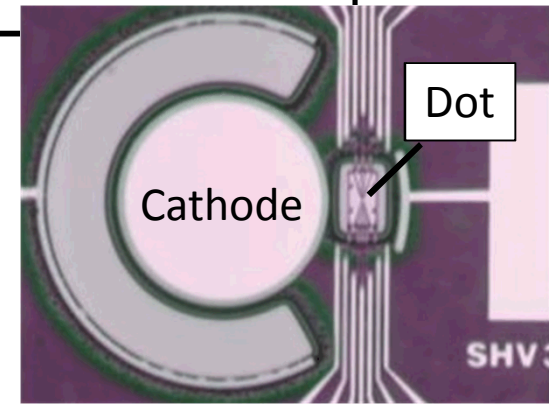
Probability of detection

0. Probability of arrival (Poisson statistics)

1. Quantum yield

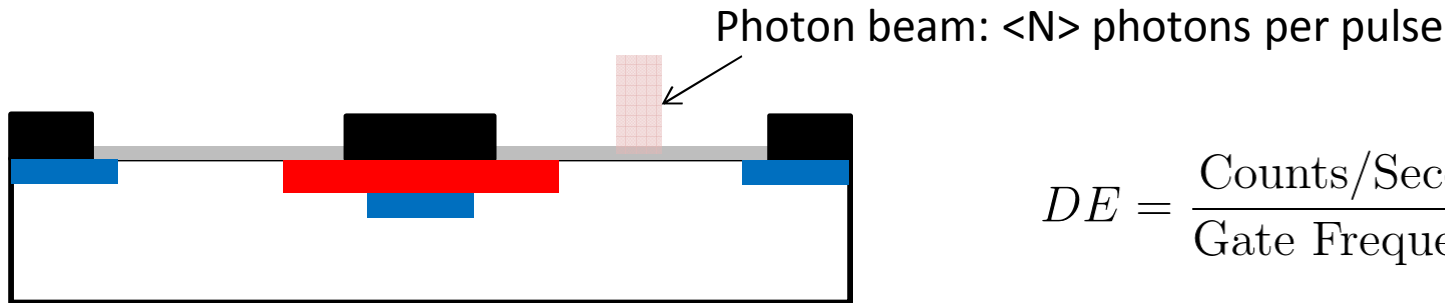
2. Probability of diffusion into the breakdown region

3. Breakdown probability



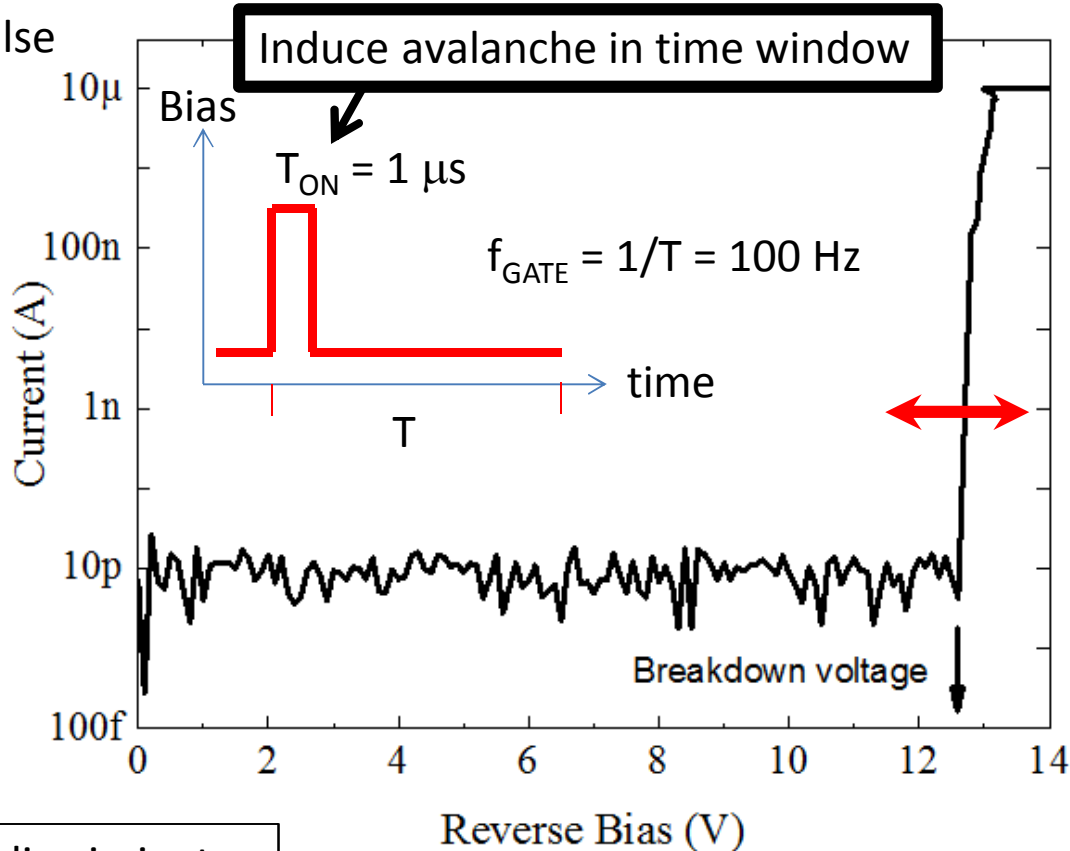
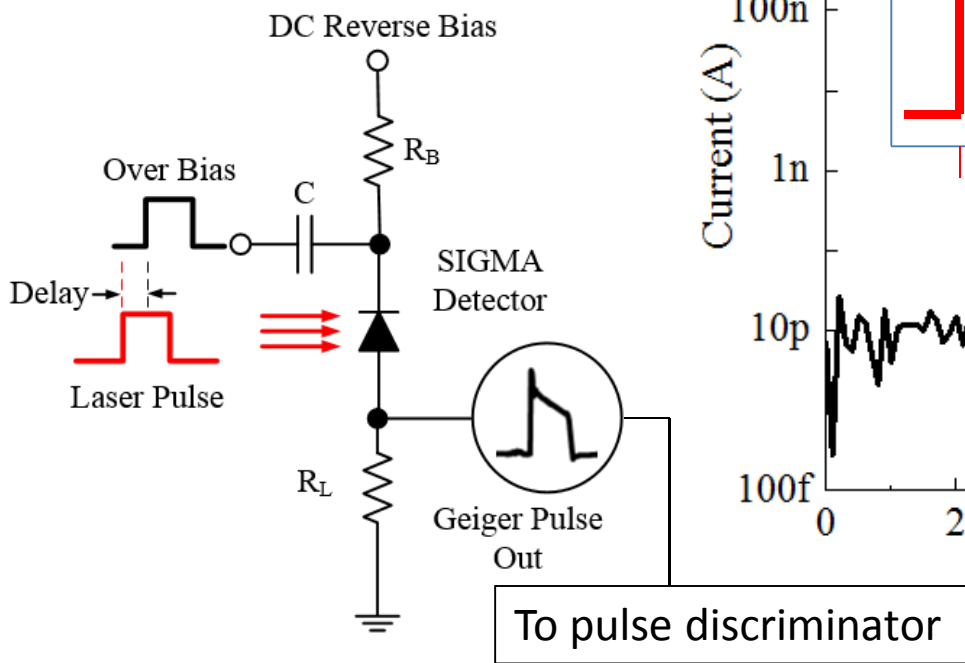
SIGMA Detector

“Geiger Mode” Detection Efficiency using Photon Pulses

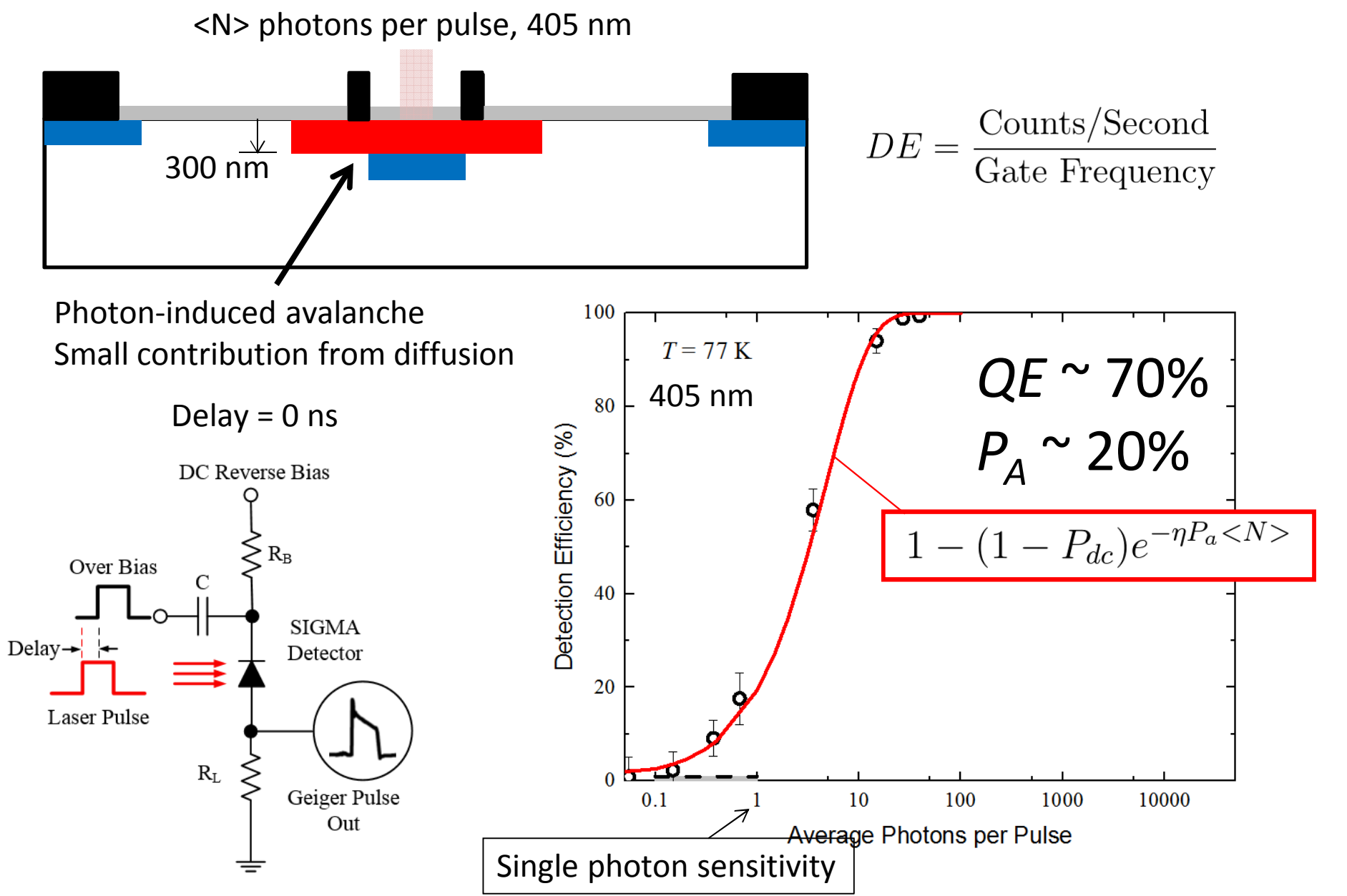


$$DE = \frac{\text{Counts/Second}}{\text{Gate Frequency}}$$

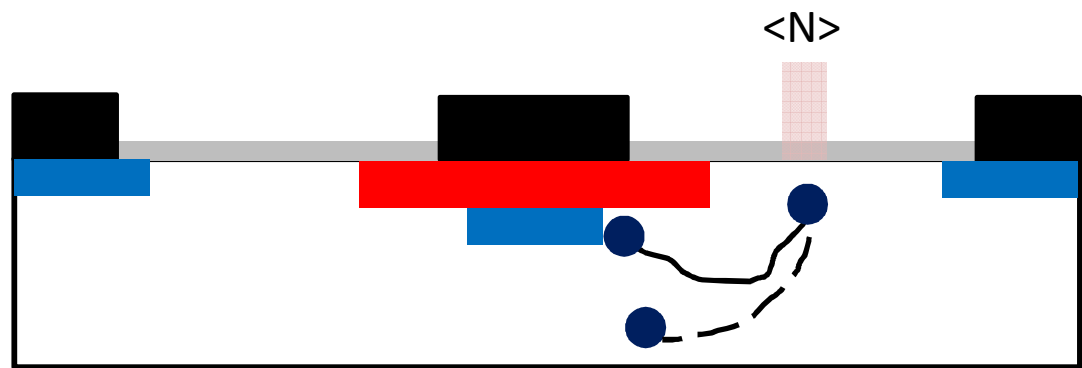
Detect: over-bias for T_{ON} , look for pulse
Turn off to “reset” the device
Count pulses for 1 second



Characterization of Detection Efficiency, Breakdown probability

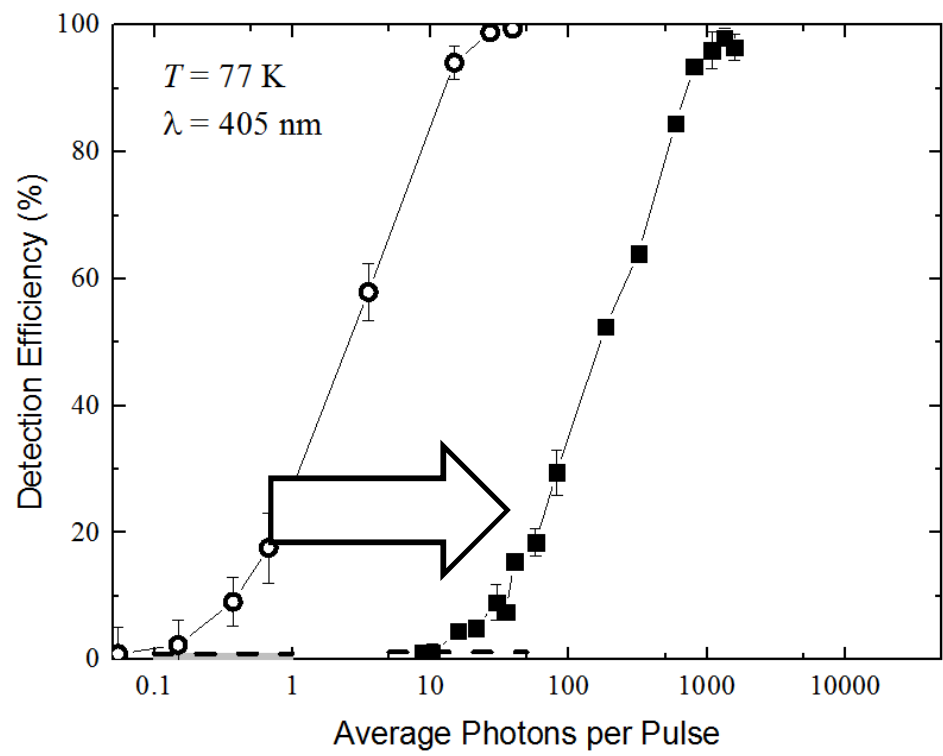
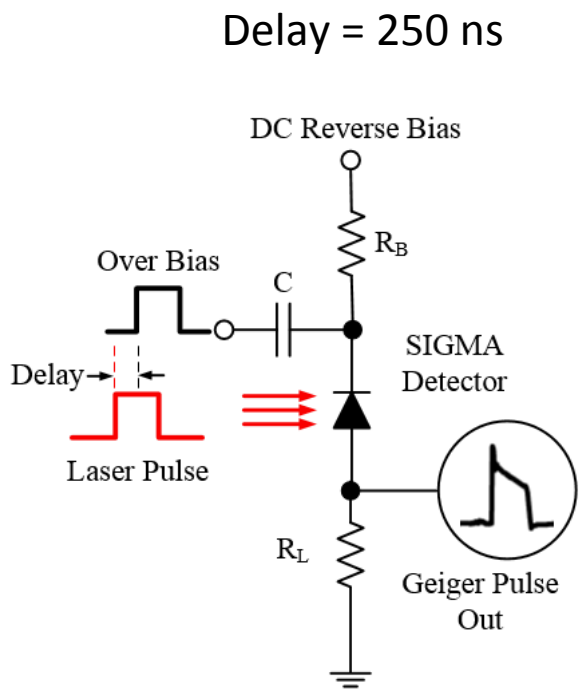


Detection Efficiency farther from the Avalanche region

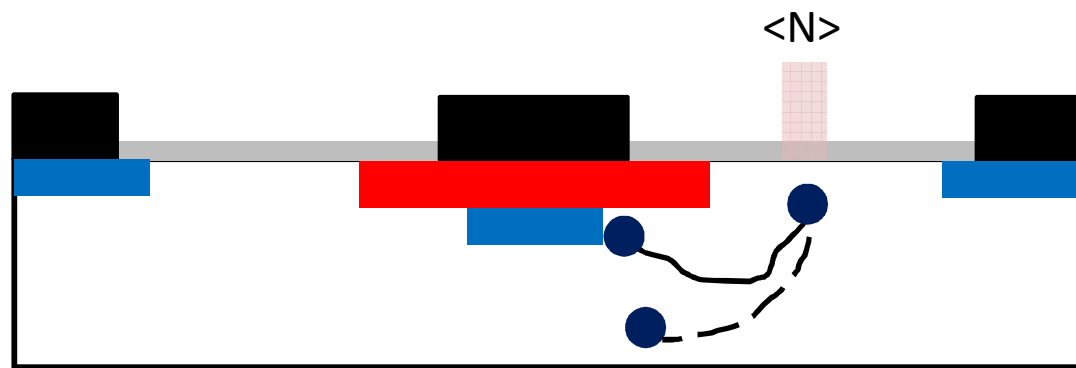


More photons/pulse needed to get same DE

Minority carriers lost to recombination as they diffuse towards avalanche region

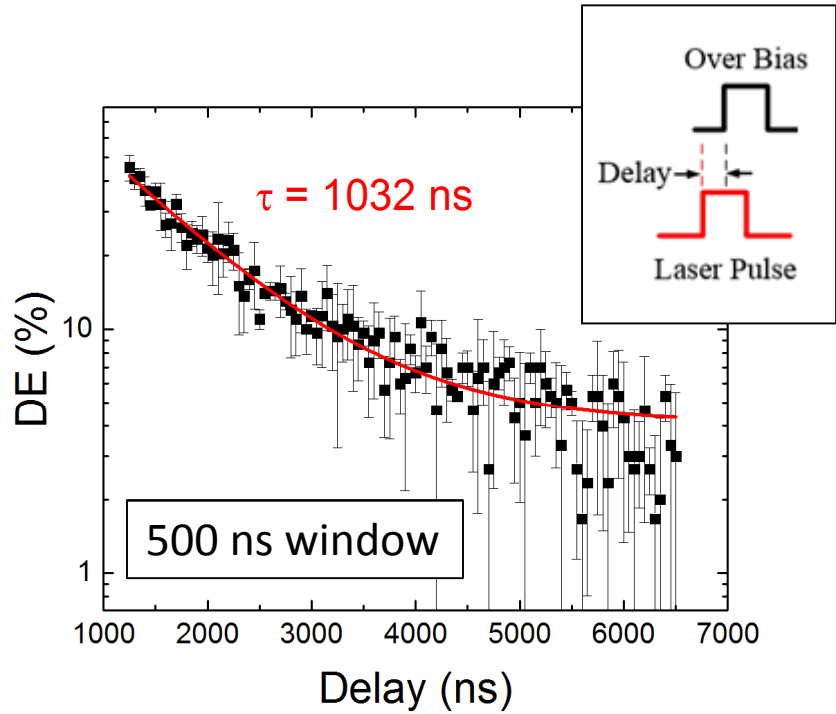
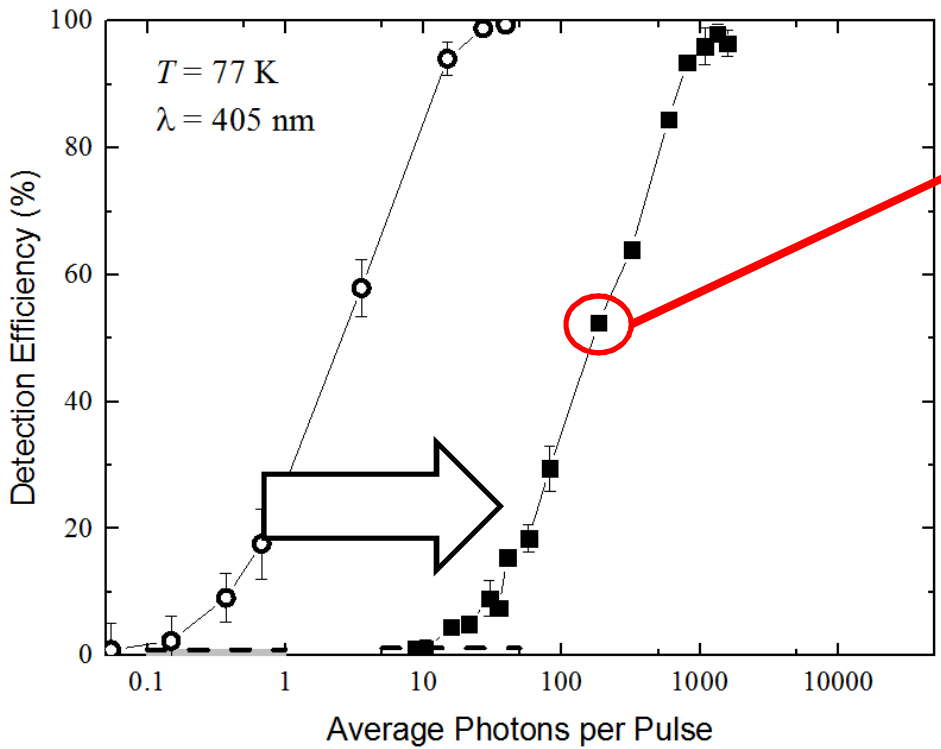


Detection Efficiency, characteristic time of arrival



Minority carriers lost to recombination as they diffuse towards avalanche region

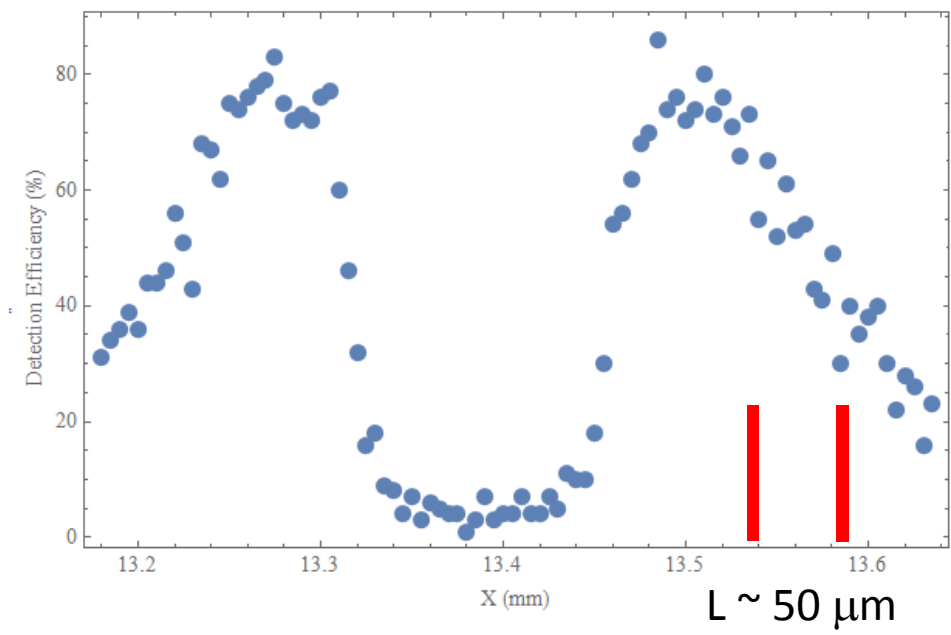
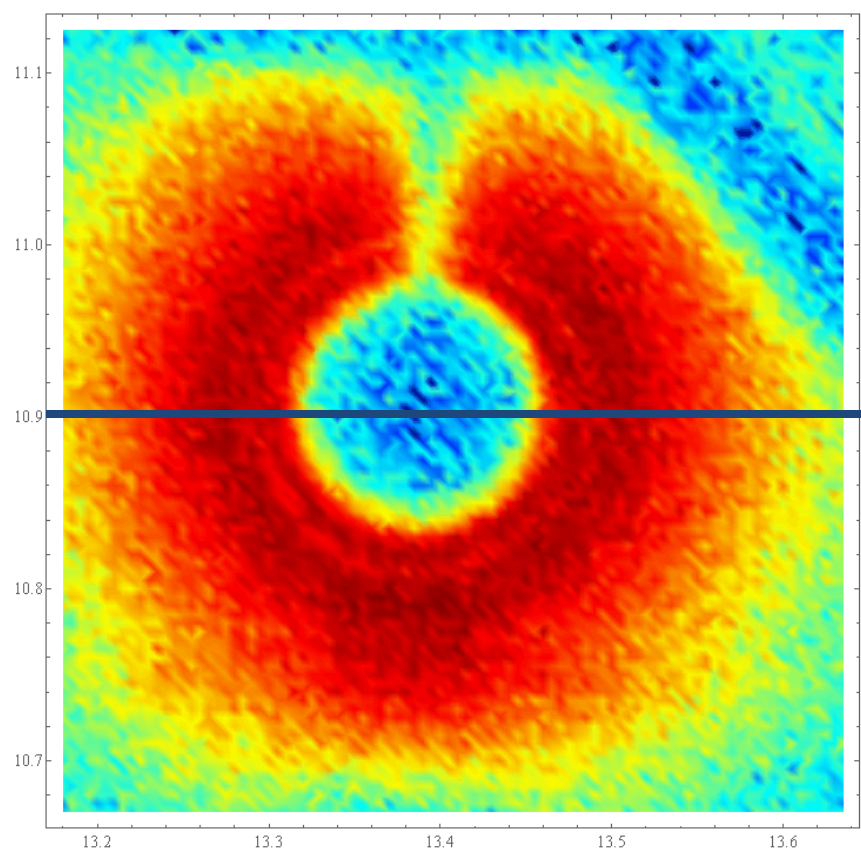
Carriers arrive at different times



$\tau \sim$ Recombination time

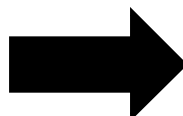
Detection Efficiency in the XY plane: characteristic length for diffusion

$\langle N \rangle = 320$ Photons/pulse, 405 nm, 77 K, Delay = 0 ns, 1 μ s pulse



Decay of Detection Efficiency: minority carrier diffusion

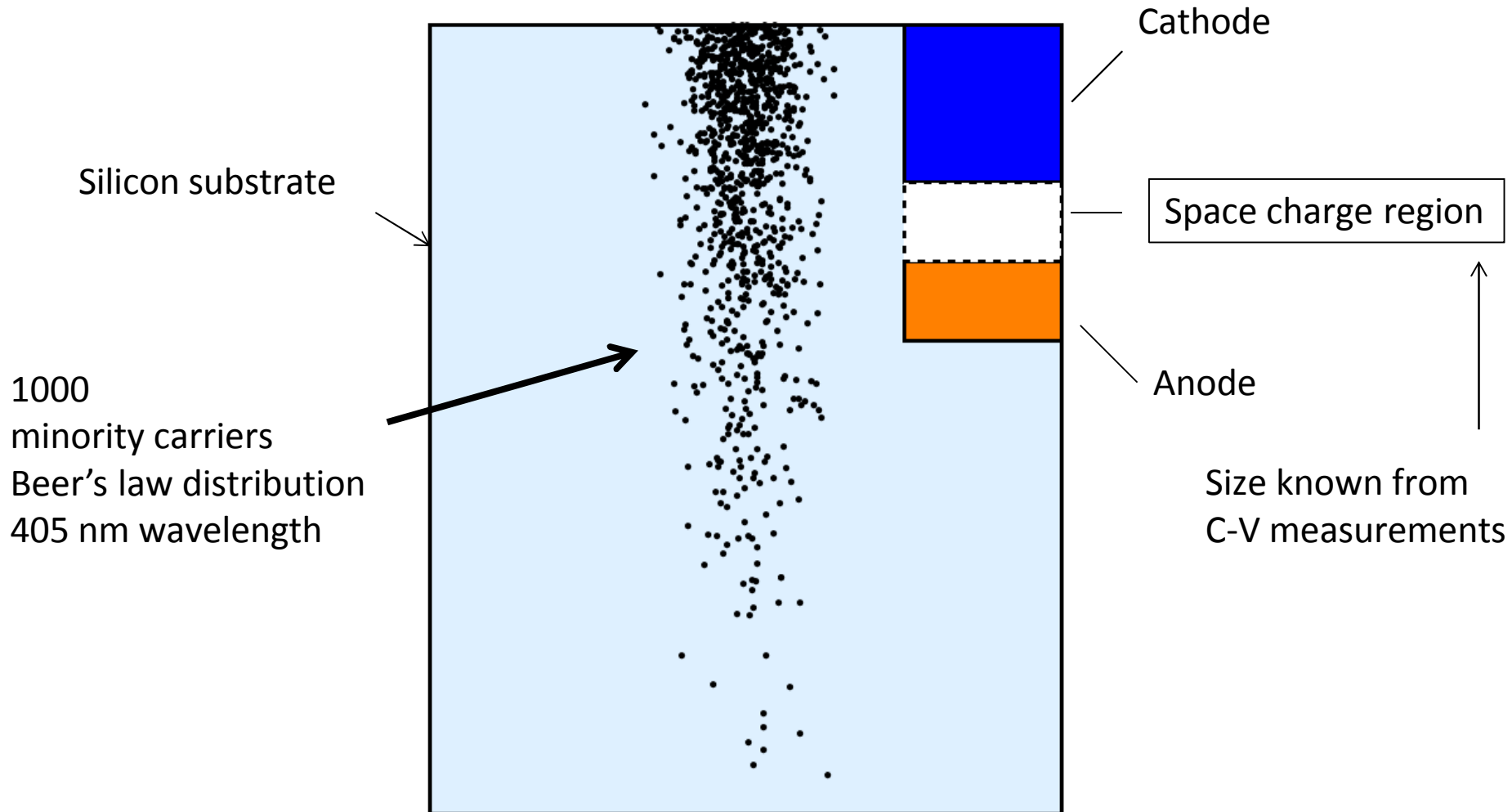
$$D \sim 37 \text{ cm}^2/\text{s}$$
$$\tau \sim 1 \mu\text{s}$$



$$L \sim \sqrt{D\tau} \sim 60 \mu\text{m}$$

2D Simulations of the SIGMA detector, set up carrier distribution

- Poisson distributed photons in
- Gaussian spot size: 40 microns



Silicon substrate

Cathode

Space charge region

Anode

1000
minority carriers
Beer's law distribution
405 nm wavelength

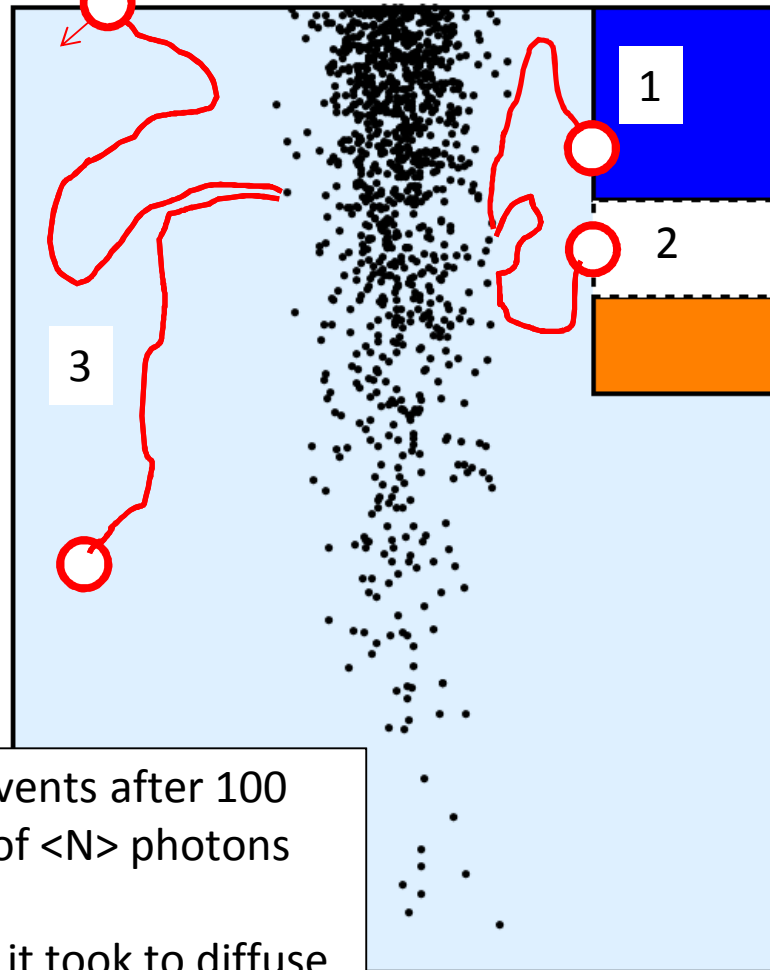
Size known from
C-V measurements

Simulations of the SIGMA Detection Efficiency

Random walk of each carrier up to 3 diffusion lengths ($v_{th} \gg v_D = \mu E$)

Ignore for now

$$L = \sqrt{D\tau}$$
$$\text{mfp} \sim 2D/v_{th}$$
$$v_{th} = \sqrt{2kT/m}$$
$$T = 77 \text{ K}$$
$$D \sim 73 \text{ cm}^2/\text{s}$$
$$\tau \sim 1 \mu\text{s}$$



Avalanche region

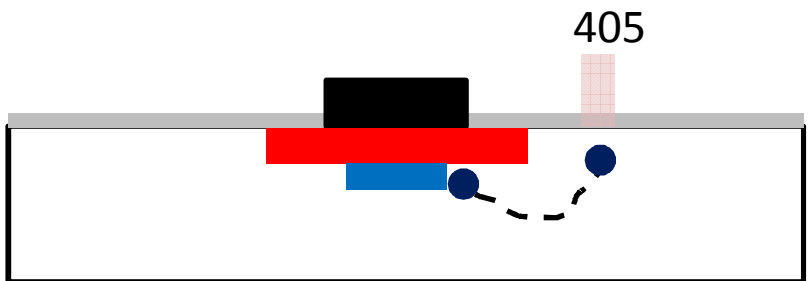
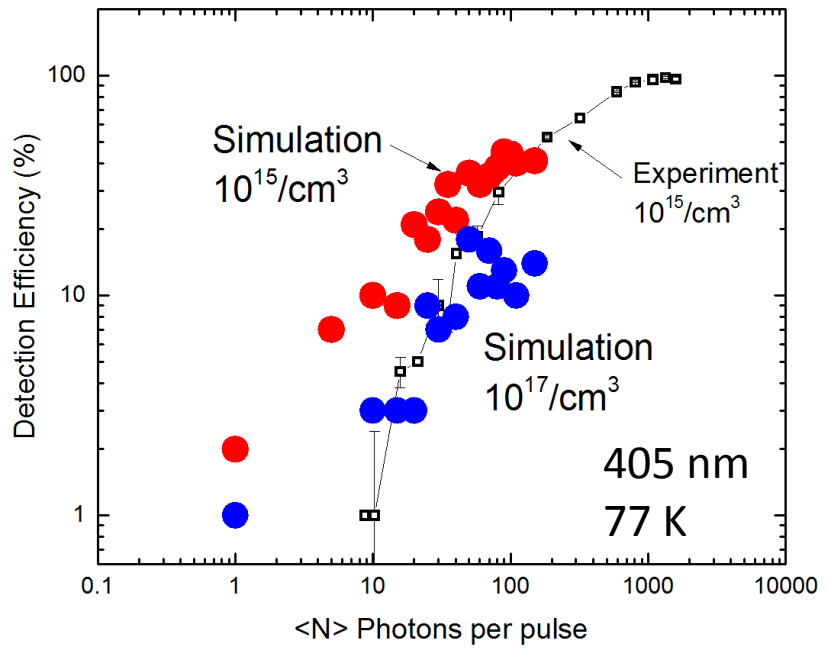
1. Recombine without an avalanche
2. Avalanche with probability $P_A = 0.2$
3. Recombine in substrate (or interface)

-Count # of avalanche events after 100 pulses with an average of $\langle N \rangle$ photons

-Keep track of how long it took to diffuse into avalanche region

Detection Efficiency versus $\langle N \rangle$ Photons per Pulse

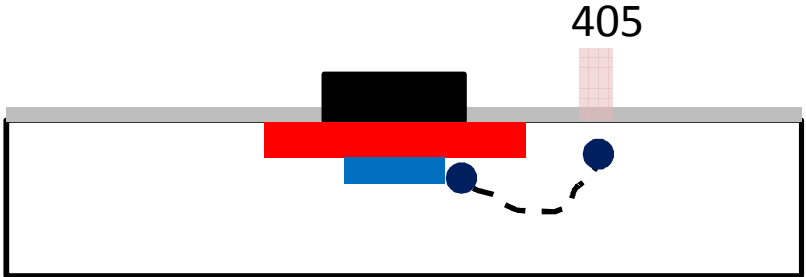
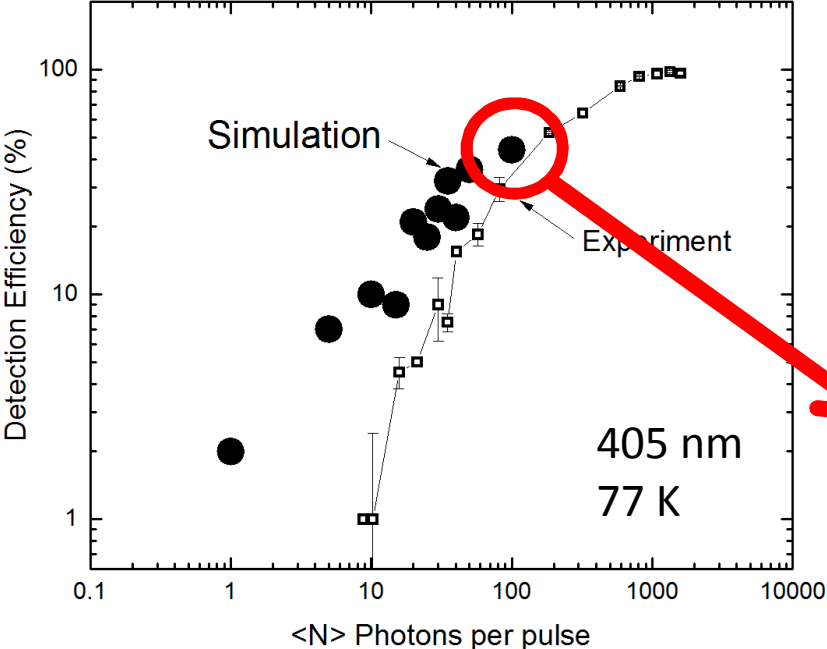
Carriers arriving up to $1\ \mu\text{s}$



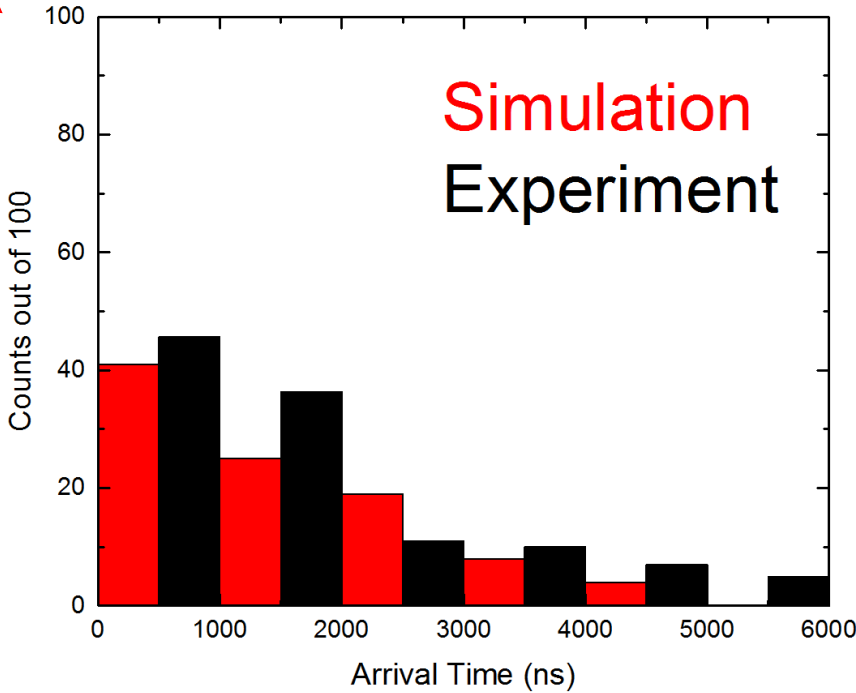
Increase background doping:
Decrease diffusion length

Diffusion/recombination of minority carriers into the detector

Carriers arriving up to 1 μs

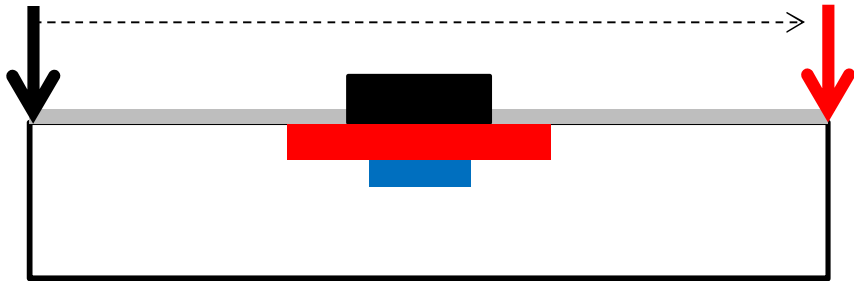


Distribution of arrival times



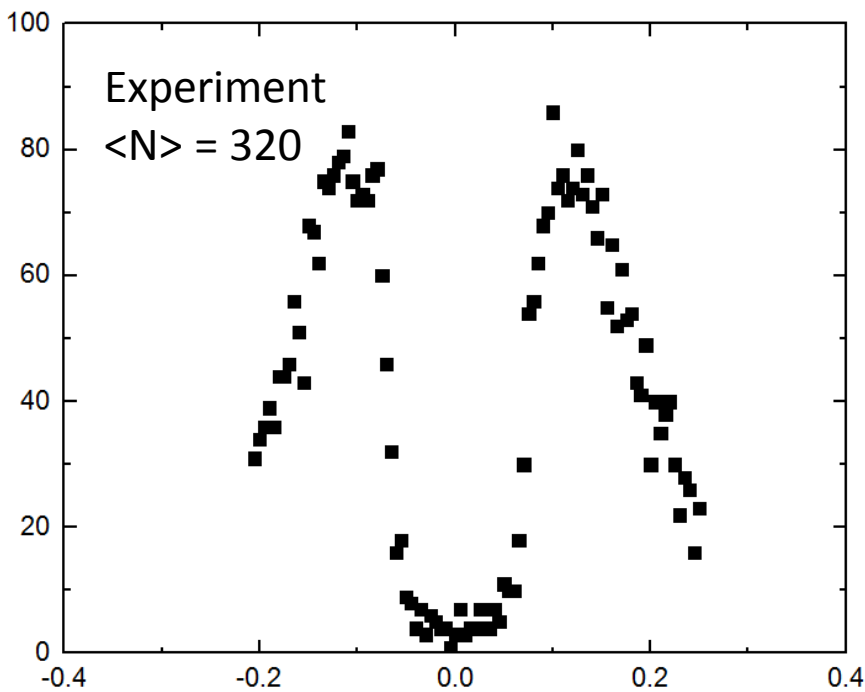
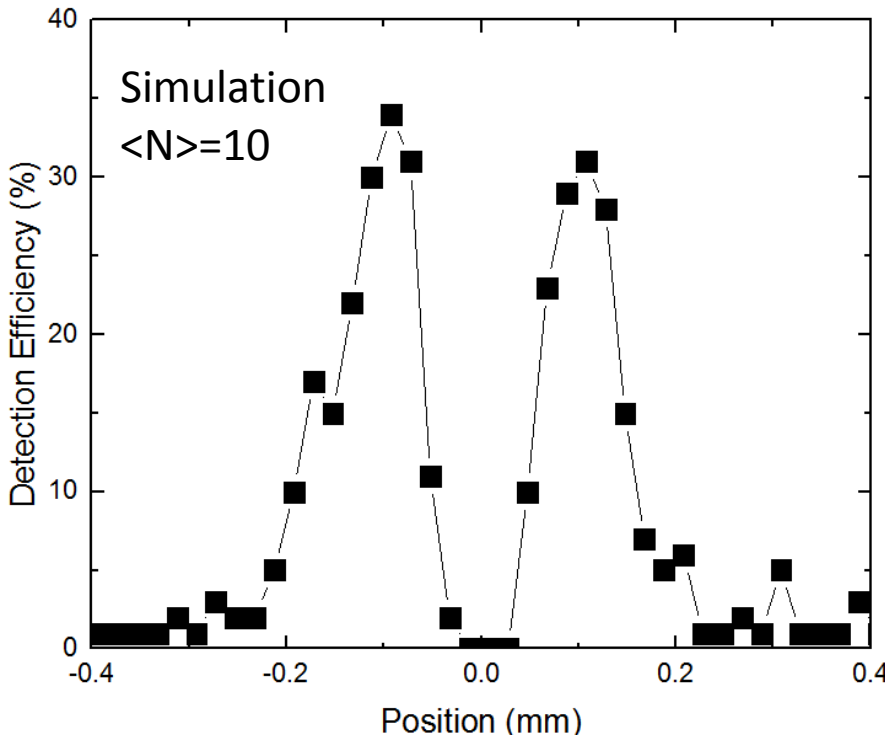
Length scale for position dependent Detection Efficiency

Laser Position



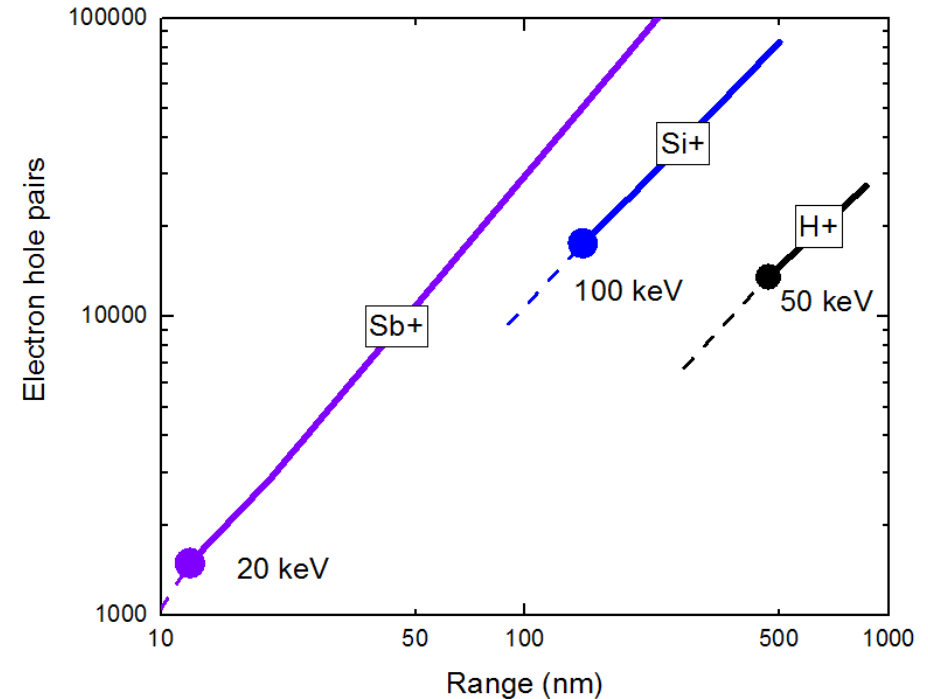
Fixed diffusivity and minority carrier recombination time

DE: count events for carriers arriving within 1 μ s



Damage-free detector performance governed by diffusion and recombination

1. Developed photon-based characterization methods without damage
2. Diffusion-recombination based Simulations of detector performance agree with measurements



What have we learned?

1. Ensure high quality bulk/interface for device
 - a. Deep level traps
 - b. SiO₂/Si interface states
2. Move the detector closer < diffusion length
3. Use an electric field to ensure transit time < recombination time

